



PATENT

Atty. Docket No. 99 P 7722 US 03 (8055-98 DIV)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT(S): Rajarao Jammy                      Examiner: Alexander G. Ghyka  
SERIAL NO.: 09/594,638                      Group Art Unit: 2812  
FILED: June 15, 2000  
FOR: METHOD FOR FORMING CRYSTALLINE SILICON  
NITRIDE

Dated: January 5, 2004


Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**TRANSMITTAL OF FORMAL DRAWINGS**

Sir:

Applicant submits herewith five (5) sheets of formal drawings  
depicting FIGS. 1-5 for this application.

Respectfully submitted,

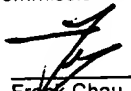
  
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**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 5, 2004.

Dated: January 5, 2004

  
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Frank Chau